



500.39750VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: OHMOTO et al

Serial No.: 10/663,646

Filed: September 17, 2003

For: Plasma Processing Apparatus

Art Unit: 1763

Examiner: R. Dhingra

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop: Box AF Amendment (Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 1, 2007

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated February 1, 2007. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.